

**AMENDMENTS TO THE CLAIMS**

The following listing of claims replaces all prior versions of the claims and all prior listings of the claims in the present application.

1. (previously presented) A mold die for molding a semiconductor device package, comprising:

a cavity block, the cavity block comprising a concave surface defining a cavity in which a semiconductor chip may be positioned, the semiconductor chip being generally rectangular and comprising a top surface, bottom surface, and four side surfaces;

a gate, the gate defining a mold resin entry into the cavity and having a gate width; and

a gate block arranged and configured for movement relative to the cavity block to provide selective opening and closing of the gate;

wherein the gate is arranged relative to the semiconductor chip whereby mold resin entering the cavity through the gate will contact two closest side surfaces of the semiconductor chip, flowing substantially parallel to the top and bottom surfaces, at an angle of less than about 70°.

2. (previously presented) A mold die for molding a semiconductor device package according to claim 1, wherein:

the cavity defined in the cavity block is substantially rectangular and comprises side walls; and

the semiconductor chip is oriented with the side surfaces generally parallel to closest side walls of the cavity.

3. (previously presented) A mold die for molding a semiconductor device package according to claim 1, wherein:

the cavity defined in the cavity block comprises four side wall segments and three corners defining a first portion of a cavity perimeter;

the semiconductor chip is oriented with the side surfaces generally parallel to the closest side wall segments; and

the gate block, when closed, forms a second portion of the cavity perimeter.

4. (previously presented) The mold die for molding a semiconductor device package according to claim 1, wherein:

a cavity perimeter is substantially rectangular when the gate is closed by the gate block.

5. (previously presented) The mold die for molding a semiconductor device package according to claim 3, wherein:

the gate block comprises an internal surface that provides the second portion of the cavity perimeter, the internal surface being positioned between a first side wall segment and a second side wall segment defined by the cavity block, and

the internal surface comprises an inclined portion that is not parallel to the first or second side wall segments.

6. (currently amended) The mold die for molding a semiconductor device package according to claim 5, wherein[[:]] the internal surface further comprises:

a first portion that is substantially parallel to the first side wall segment and a second portion that is substantially parallel to the second side wall segment.

7. (previously presented) The mold die for molding a semiconductor device package according to claim 5, wherein:

the internal surface is substantially identical to the inclined portion of the internal surface, and

the gate width is substantially identical to a length of the inclined portion.

8. (previously presented) The mold die for molding a semiconductor device package according to claim 5, wherein:

a third side wall segment is positioned opposite and generally parallel to the first side wall segment, the third side wall segment being longer than the first side wall segment;

a fourth side wall segment is positioned opposite and generally parallel to the second side wall segment, the fourth side wall segment being longer than the second side wall segment; and

the gate width is at least equal to one-half of a first length and is less than a second length, wherein the first length is equal to the shorter of the third and fourth side wall segments and the second length is equal to the longer of the third and fourth side wall segments.

9. (previously presented) The mold die for molding a semiconductor device package according to claim 8, wherein:

the internal surface is symmetric about an axis extending from a corner of the cavity opposite the gate and extending through a center of the cavity.

10. (previously presented) A mold die for molding a chip array package, comprising:  
a plurality of semiconductor chips;  
a cavity block, the cavity block comprising a concave surface defining a cavity in which the plurality of semiconductor chips may be positioned, the plurality of semiconductor chips being generally rectangular and comprising a top surface, bottom surface, and four side surfaces;  
a gate, the gate defining a mold resin entry into the cavity and having a gate width; and  
a gate block arranged and configured for movement relative to the cavity block to provide selective opening and closing of the gate;  
wherein the gate is arranged relative to the plurality of semiconductor chips whereby mold resin entering the cavity through the gate will contact two closest side surfaces of the plurality of semiconductor chips, flowing substantially parallel to the top and bottom surfaces, at an angle of less than about 70°.

11. (original) A mold die for molding a chip array package according to claim 10, wherein:  
at least two of the plurality of semiconductor chips are arranged in a stacked orientation with bonding wires providing electrical connection between an upper semiconductor chip and a lower semiconductor chip.

12. (previously presented) A molding apparatus for molding a chip array, comprising:  
a mold die according to claim 1, wherein the cavity is arranged and configured to receive a plurality of aligned semiconductor chips comprising side surfaces, and wherein the gate is

arranged and configured so that mold resin entering the cavity through the gate will approach the side surfaces;

a pot for maintaining mold resin; and

a channel block defining a fluid path between the pot and the gate block.

13. (previously presented) A molding apparatus for molding a plurality of chip arrays, comprising:

a plurality of mold dies according to claim 1;

a pot for maintaining mold resin; and

a channel block defining a plurality of fluid paths between the pot and the plurality of mold dies.

14. (previously presented) A method for molding a semiconductor device package using a mold die according to claim 1, comprising:

arranging a semiconductor chip within the cavity, the semiconductor chip comprising side surfaces;

moving the gate block to open the gate;

injecting a flow of mold resin into the cavity through the gate to fill the cavity;

moving the gate block to close the gate;

solidifying the mold resin within the cavity to form the semiconductor device package;

and

removing the semiconductor device package from the cavity;

wherein the gate is configured and positioned such that the flow of mold resin approaches two closest side surfaces of the semiconductor chip at an angle of less than 90°.

15. (previously presented) A method for molding a semiconductor device package using a mold die according to claim 1, comprising:

arranging a semiconductor chip within the cavity, the semiconductor chip comprising side surfaces and a plurality of bonding wires arranged adjacent to the side surfaces for providing electrical connection between the semiconductor chip and a substrate;

moving the gate block to open the gate;

injecting a flow of mold resin into the cavity through the gate to fill the cavity;

moving the gate block to close the gate;

solidifying the mold resin within the cavity to form the semiconductor device package;

and

removing the semiconductor device package from the cavity,

wherein the gate is configured and positioned such that the mold resin flows past all bonding wires adjacent to a single side surface of the semiconductor chip in a generally uniform direction.

16. (previously presented) A method for molding a semiconductor device package using a mold die according to claim 15, comprising:

arranging a semiconductor chip within the cavity, the semiconductor chip comprising side surfaces and a plurality of bonding wires arranged adjacent to the side surfaces for providing electrical connection between the semiconductor chip and a substrate, wherein the bonding wires

are arranged so as to provide a region of low bonding wire density adjacent to a first corner of the semiconductor chip;

wherein the gate is configured and positioned such that the mold resin separates into two flows as the mold resin reaches a second corner of the semiconductor chip, the second corner being located diagonally across the semiconductor chip from the first corner, the two mold resin flows recombining near the region of low bonding wire density.

17. (previously presented) A mold die for molding a semiconductor device package, comprising:

a cavity block, the cavity block comprising a concave surface defining a cavity in which a semiconductor chip may be positioned, the semiconductor chip being generally rectangular and comprising a top surface, bottom surface, and four side surfaces;

a gate, the gate defining a mold resin entry into the cavity and having a gate width; and

a gate block arranged and configured for movement relative to the cavity block to provide selective opening and closing of the gate;

wherein the gate is arranged relative to the semiconductor chip whereby mold resin entering the cavity through the gate will contact two closest side surfaces of the semiconductor chip at an angle of less than about 70°, measured in a plane substantially parallel to the top and bottom surfaces.

18. (previously presented) A mold die for molding a chip array package, comprising:

a plurality of semiconductor chips;

a cavity block, the cavity block comprising a concave surface defining a cavity in which the plurality of semiconductor chips may be positioned, the plurality of semiconductor chips being generally rectangular and comprising a top surface, bottom surface, and four side surfaces;

a gate, the gate defining a mold resin entry into the cavity and having a gate width; and

a gate block arranged and configured for movement relative to the cavity block to provide selective opening and closing of the gate;

wherein the gate is arranged relative to the plurality of semiconductor chips whereby mold resin entering the cavity through the gate will contact two closest side surfaces of the plurality of semiconductor chips at an angle of less than about  $70^{\circ}$ , measured in a plane substantially parallel to the top and bottom surfaces.